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FACSIMILE COVER SHEET

DATE: November 21, 2005

FILE NO: APPM/007034.P1/DSM/LOW K/JW

TO: MAIL STOP AF

FAX NO: 571-273-8300

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FROM: Keith M. Tackett

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ORIGINAL TO FOLLOW? YES NO

SECOND RESPONSE TO FINAL OFFICE ACTION DATED AUGUST 26, 2005

TITLE: Ultra Low Dielectric Materials Based on Hybrid System of
 Linear Silicon Precursor and Organic Porogen by Plasma-
 Enhanced Chemical Vapor Deposition (PECV)
 U.S. SERIAL NO.: 10/773,060
 FILING DATE: February 4, 2004
 INVENTOR: Yim, et al.
 EXAMINER: Marianne L. Padgett
 GROUP ART UNIT: 1762
 CONFIRMATION NO.: 5473

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PATENT

Atty. Dkt. No. APPM/007034.P1/DSM/LOW KJW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Yim, et al.

Serial No.: 10/773,060

Confirmation No.: 5473

Filed: February 4, 2004

For: Ultra Low Dielectric Materials
Based on Hybrid System of Linear
Silicon Precursor and Organic
Porogen by Plasma-Enhanced
Chemical Vapor Deposition
(PECVD)MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

§ Group Art Unit: 1762

§ Examiner: Marianne L. Padgett

CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8

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SECOND RESPONSE TO FINAL OFFICE ACTION DATED AUGUST 26, 2005

In response to the Final Office Action dated August 26, 2005, having a shortened statutory period for response set to expire on November 26, 2005, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/007034.P1/KMT for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are listed beginning on page 2 of this paper.
Remarks begin on page 5 of this paper.

Page 1

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